## Notice of References Cited Application/Control No. 10/634,671 Examiner Minh D A Applicant(s)/Patent Under Reexamination TSAI, TSUNG-JUNG Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2003/0141845	07-2003	Krieger et al.	320/132
	В	US-6,034,489	03-2000	Weng, Da Feng	315/307
	С	US-5,410,221	04-1995	Mattas et al.	315/307
	D	US-5,404,082	04-1995	Hernandez et al.	315/219
	E	US-6,127,788	10-2000	Yamamoto et al.	315/307
	F	US-6,124,681	09-2000	Choi, Hyun Bae	315/291
	G	US-5,384,518	01-1995	Kido et al.	315/225
·	Н	US-			
	l	US-			
	J	US-			
	К	US-			
	L	US-			
- 1	М	US-			

## FOREIGN PATENT DOCUMENTS

TOTALIST FACILITY								
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification		
	N			1.004				
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	Р					J		
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	R							
<u> </u>	S							
	Т					•		

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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